

# Eigenvalues, Resonance Poles, and Damping in MEMS

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MEMS  
Motivation

Simple 1D  
Model

Unbounded  
Domain  
Approximation

PML and  
Resonance  
Poles

# Outline

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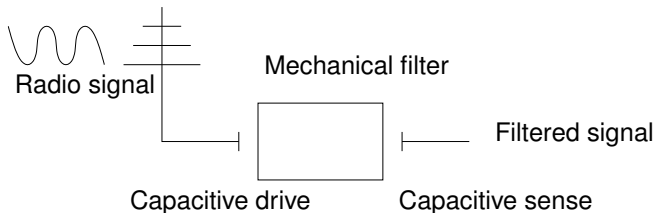
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# Resonating MEMS



- Mechanical high-frequency (high MHz-GHz) filter
  - Your cell phone is mechanical!
  - New MEMS filters can be integrated with circuitry
    - ⇒ smaller and lower power
- Can also make MEMS frequency references, resonant sensors, ...

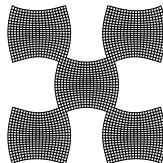
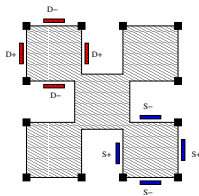
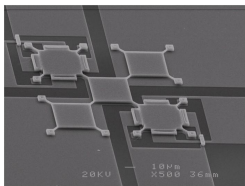
# Resonant MEMS: Checkerboard

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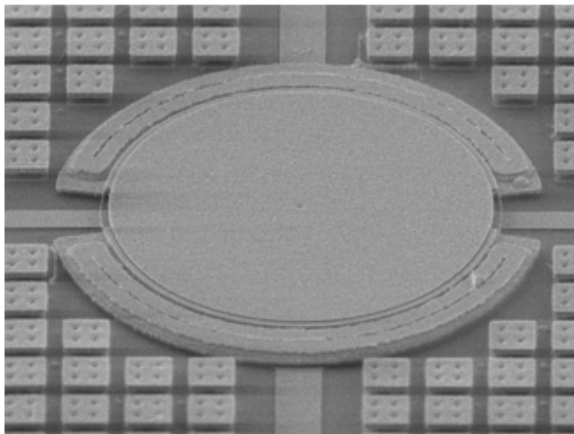
# Resonant MEMS: Disk resonator

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SiGe disk resonators built by E. Quévy

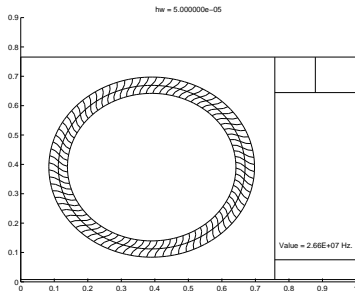
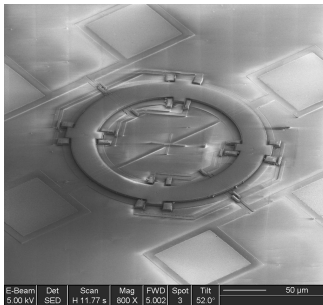
# Resonant MEMS: Shear ring

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# Transfer Functions

Time domain:

$$\begin{aligned}Mu'' + Bu' + Ku &= b\phi(t) \\ y(t) &= p^T u\end{aligned}$$

Laplace domain:

$$\begin{aligned}s^2 M \hat{u} + sB \hat{u} + K \hat{u} &= b \hat{\phi}(s) \\ \hat{y}(s) &= p^T \hat{u}\end{aligned}$$

Transfer function:

$$\begin{aligned}H(s) &= p^T (s^2 M + sB + K)^{-1} b \\ \hat{y}(s) &= H(s) \hat{\phi}(s)\end{aligned}$$

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# Think Globally, Approximate Locally

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Want to treat subsystems like simple circuits

- Pick a simple circuit topology
- Pick a target resonant frequency  $\omega_0$
- Approximate  $H(s)$  near  $i\omega_0$  by circuit transfer function

# Example: Equivalent Circuit for Disk

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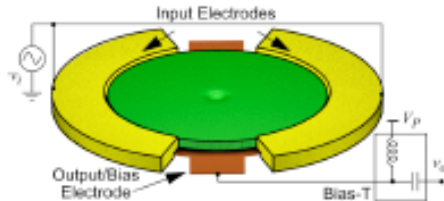


Fig. 8. Perspective view of a one-port measurement setup. (Color version available online at <http://ieeexplore.ieee.org>.)



Fig. 9. Equivalent circuit for the radial-contour mode disk operated as a one-port.

(Clark, Hsu, Abdelmoneum, Nguyen. JMEMS 11 (6))

# Damping and $Q$

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Designers want high *quality of resonance* ( $Q$ )

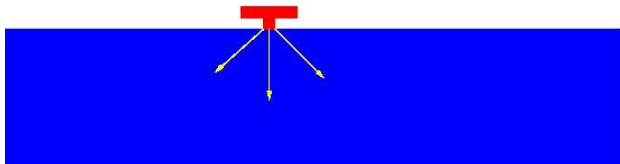
- Dimensionless damping in a one-dof system

$$\frac{d^2 u}{dt^2} + Q^{-1} \frac{du}{dt} + u = F(t)$$

- For a resonant mode with frequency  $\omega \in \mathbb{C}$ :

$$Q := \frac{|\omega|}{2 \operatorname{Im}(\omega)} = \frac{\text{Stored energy}}{\text{Energy loss per radian}}$$

# Damping Mechanisms



Possible loss mechanisms:

- Fluid damping
- Material losses
- Thermoelastic damping
- **Anchor loss**

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# ... Where Angels Fear to Tread

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Wait a moment:

- When is a domain “effectively semi-infinite?”
- What do the model modes mean?
- How do I estimate the overall accuracy?

# Simple String Model

One-dimensional wave problem:

$$s^2 \rho u = \sigma_x, \quad x \in (0, 1)$$

$$\sigma = E u_x$$

$$u(0, s) = u_0(s)$$

$$u(1, s) = 0.$$

Solutions have the form

$$u(x, s) = d \sin k(x - 1)$$

$$d = -1 / \sin(k)$$

$$s = i\omega$$

$$k = \omega \sqrt{\rho/E} = \omega/c.$$

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# Dynamic Stiffness

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Dynamic stiffness at  $x = 0$  is

$$\begin{aligned}\kappa(\mathbf{s}) &:= \frac{\sigma(0, \mathbf{s})}{u(0, \mathbf{s})} \\ &= -Ek \cot(k)\end{aligned}$$

where  $k = \omega/c = \omega\sqrt{\rho/E}$

Poles at  $k = n\pi$ ,  $n \neq 0$ .



# Viscoelastic String Model

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Now make the constitutive relation hysteretic:

$$s^2 \rho u = \sigma_x, \quad x \in (0, 1)$$

$$\sigma = E(s)u_x$$

$$u(0, s) = u_0(s)$$

$$u(1, s) = 0.$$

where  $E(s)$  has poles only on the negative real  $s$  axis.

Free vibrations solve a *nonlinear* eigenproblem.

# Dynamic Stiffness

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As before, dynamic stiffness is

$$\begin{aligned}\kappa(\mathbf{s}) &:= \frac{\sigma(0, \mathbf{s})}{u(0, \mathbf{s})} \\ &= -E(\mathbf{s})k \cot(k)\end{aligned}$$

but now  $k = \omega/c = \omega\sqrt{\rho/E(i\omega)}$ .

# Perturbation for Isolated Singularities

Where  $E(i\omega) \approx E_0$ ,  $E_0$  a real constant, can approximate (isolated) poles by perturbation. Poles at

$$\omega \approx \omega_0 (1 + 2 \tan \delta)$$

where

$$\begin{aligned}\omega_0 &= n\pi c_0 = n\pi \sqrt{E_0/\rho} \\ \tan \delta &= \frac{\text{Im}(E(i\omega_0))}{\text{Re}(E(i\omega_0))}.\end{aligned}$$

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# Long Viscoelastic String

Now change length:

$$\begin{aligned}s^2 \rho u &= \sigma_x, \quad x \in (0, L) \\ \sigma &= E(s) u_x \\ u(0, s) &= u_0(s) \\ u(L, s) &= 0.\end{aligned}$$

Dynamic stiffness becomes

$$\kappa_L = -Ek \cot(Lk)$$

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# Dynamic Stiffness as $L \rightarrow \infty$

Consider asymptotic behavior:

$$\begin{aligned}\kappa_L &= -Ek \cot(Lk) \\ &= -ikE \frac{e^{ikL} + e^{-ikL}}{e^{ikL} - e^{-ikL}} \\ &= \begin{cases} -ikE(1 + O(e^{-2ikL})) \\ -ikE(-1 + O(e^{2ikL})) \end{cases}\end{aligned}$$

Pointwise convergence almost everywhere to

$$\kappa_\infty = \begin{cases} -ikE, \operatorname{Im}(k) > 0 \\ ikE, \operatorname{Im}(k) < 0 \end{cases}$$

No convergence along  $\operatorname{Im}(k) = 0$ .

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# Dynamic Stiffness as $L \rightarrow \infty$

Limiting function is

$$\kappa_{\infty} = -ik^+ E$$

where  $k^+$  is the root of

$$k^2 = \omega^2 \frac{E(i\omega)}{\rho}$$

chosen so that  $\text{Im}(k^+) > 0$ . Have a branch cut along

$$\omega^2 E(i\omega) > 0.$$

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# From Long to Infinite

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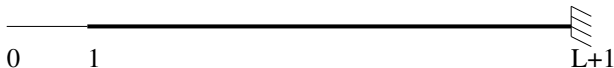
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- As  $L \rightarrow \infty$ , eigenvalues cluster along a curve
- Away from this curve,  $\kappa_L$  converges pointwise to  $\kappa_\infty$
- Curve is a branch cut in definition of  $\kappa_\infty$



# Large Absorbing Domain



$$s^2 \rho_1 u(x, s) = \sigma(x, s), \quad x \in (0, 1)$$

$$s^2 \rho_2 u(x, s) = \sigma(x, s), \quad x \in (1, L+1)$$

$$\sigma(x, s) = E_1(s) u_x(s), \quad x \in (0, 1)$$

$$\sigma(x, s) = E_2(s) u_x(s), \quad x \in (1, L+1)$$

$$u(0, s) = u_0(s)$$

$$u(0, L+1) = 0$$

And continuity of  $u$  and  $\sigma$  across  $x = 1$ .

# Dynamic Stiffness

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$$\kappa_L = -E_1 k_1 \frac{\cos(k_1) + i\tilde{\xi} \sin(k_1)}{\sin(k_1) - i\tilde{\xi} \cos(k_1)}.$$

where

$$\delta = e^{-2ik_2L}$$

$$\xi = \frac{E_1 k_1}{E_2 k_2} = \sqrt{\frac{\rho_1 E_1}{\rho_2 E_2}}$$

$$\tilde{\xi} = \xi \frac{1 - \delta}{1 + \delta}.$$

If  $\xi = 0$ , recover the clamped case.

# Asymptotic Behavior

Choose  $k_2^-$  such that  $\text{Im}(k_2^-) < 0$ . As  $L \rightarrow \infty$ ,  $|\delta| \rightarrow 0$ , and

$$\kappa_\infty = -E_1 k_1 \frac{\cos(k_1) + i\xi \sin(k_1)}{\sin(k_1) - i\xi \cos(k_1)}.$$

Poles of  $\kappa_\infty$  satisfy:

$$\tan(k_1) = i\xi$$

Taylor expand to approximate pole location:

$$k_1 \approx n\pi + i\xi_0.$$

where  $\xi_0$  is the value of  $\xi$  at  $k_1 = n\pi$ .

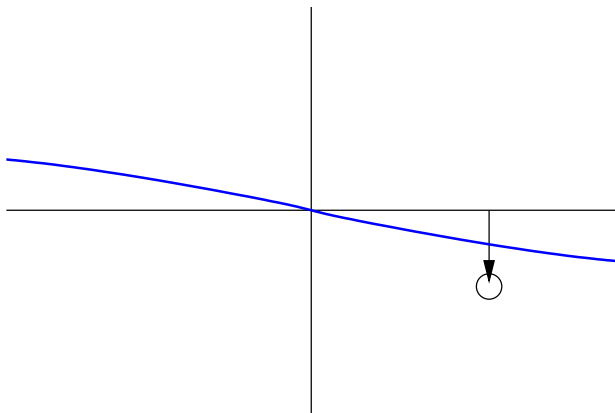
# Resonance Poles

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We chose a principle value for  $k_2$  – but the singularity occurs on the other sheet!

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# Approximation Steps

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- Isolated poles near real  $\omega \implies$  simple approximation
- As  $L \rightarrow \infty$ , poles cluster
- As  $L \rightarrow \infty$ , convergence to infinite domain a.e.
- Infinite domain has branch cuts and resonance poles
- Isolated resonance poles near real  $\omega \implies$  simple approximation

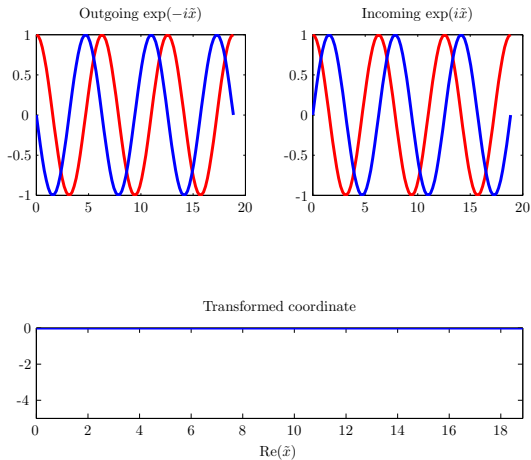
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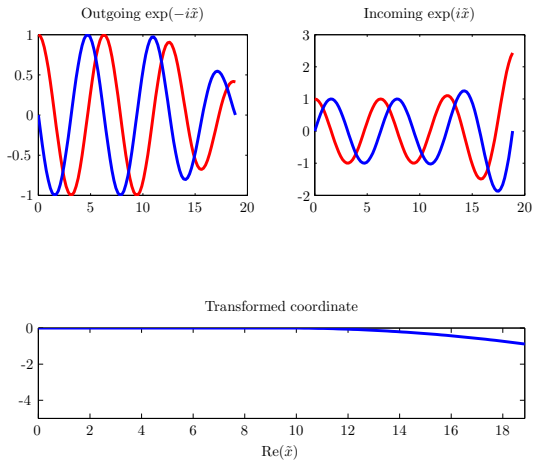
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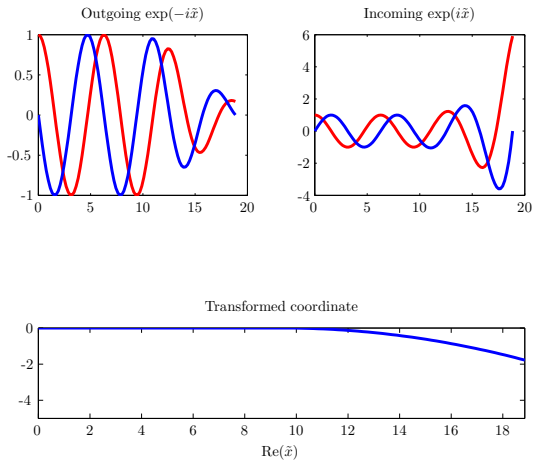
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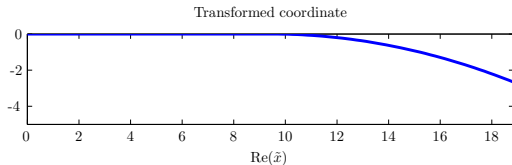
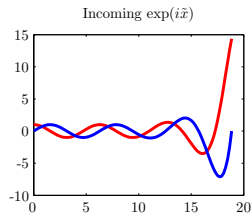
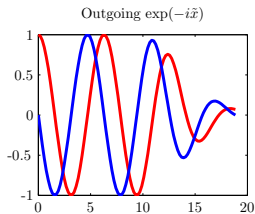
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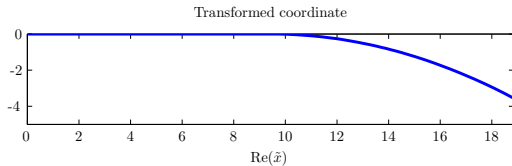
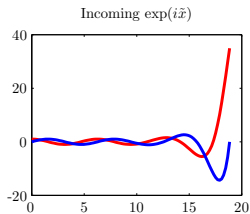
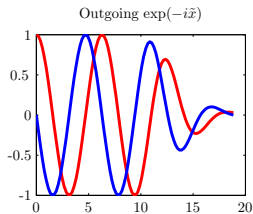
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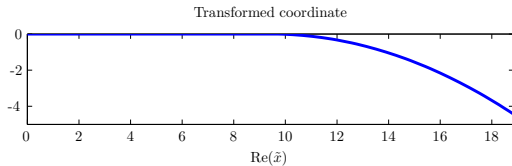
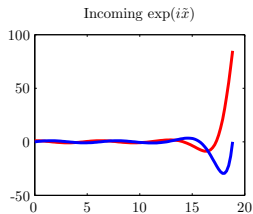
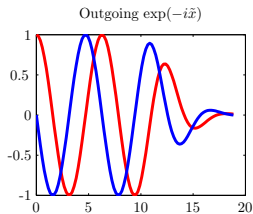
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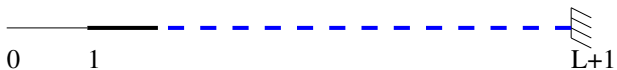
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Take inhomogeneous problem from before and add PML:



- For real  $\omega$ , same limiting dynamic stiffness
- But the branch cut is in a different place!
- Means resonance poles become true poles

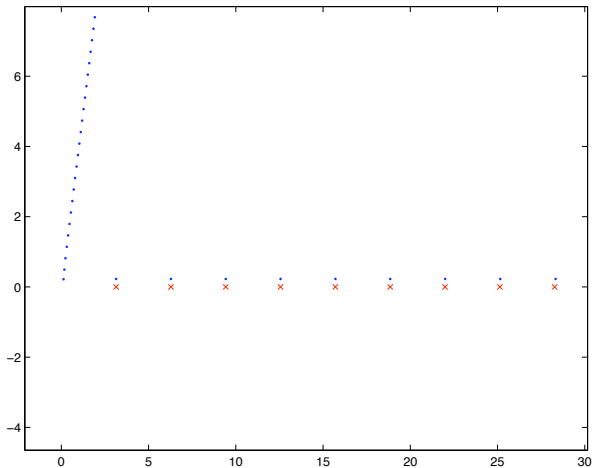
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# Conclusions

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- Modal analysis gives good approximations near isolated poles
- Large, damped domains  $\implies$  clustered poles
- Away from poles, converges to unbounded problem
- Unbounded problem has branch cuts, resonance poles
- PML moves branch cuts, reveals the resonance poles
- Analysis gives good approximations to original problem near isolated resonance poles